

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT Hypo

In re Application of:

Gurtei S. Sandhu

Serial No.: 09/023,146

Filed: February 12, 1998

For: TUNGSTEN SILICIDE (WSIx) DEPOSITION PROCESS FOR

SEMICONDUCTOR MANUFACTURE

Examiner: T. Dang

Group Art Unit: 2823

Attorney Docket No.: 3369.1US

(91-365-RE)

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PRELIMINARY AMENDMENT

Box CPA Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

Please amend the above-identified application as follows.

IN THE CLAIMS:

Please amend claim 33 as follows: